

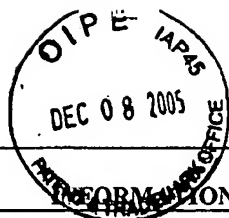
INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)				Attorney Docket No.: 046124-5388		Serial No.: 10/537,509	
PTO Form 1449				Applicants Fumitsugu FUKUYO et al.		Page 1 of 2	
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						YES	NO
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JG	07-037840	February 7, 1995	JP			Abstract	
JG	2000-124537	April 28, 2000	JP			Abstract	

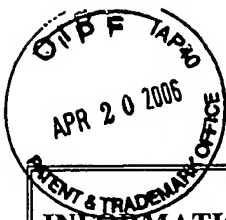
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JG		05-335726	Dec. 17, 1993	Japan			X (abstract)	
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